

ATTORNEY DOCKET NO.
TI-35862 (32350.B534)

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: DeLoach, et al.
Filed: November 6, 2003
For: *Forming a Trench to Define One or More
Isolation Regions in a Semiconductor Structure*

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

Applicants respectfully request, pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98, that the reference listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified patent application. No representation is made that a search has been made, that this reference is material to the patentability of the present application, or that this reference qualifies as prior art. This Information Disclosure Statement is being submitted pursuant to 37 C.F.R. § 1.97(b).

Since the present Application was filed after June 30, 2003, a copy of the U.S. patent cited on the attached PTO Form 1449 is not being submitted with this Information Disclosure

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PATENT APPLICATION

Statement pursuant to the July 11, 2003 waiver of 37 C.F.R. § 1.98(a)(2)(i) by the United States Patent and Trademark Office.

Respectfully submitted,

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Date: November 6, 2003

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23494

PTO-1449 Information Disclosure Citation In an Application	Application No.		Applicant(s) DeLoach, et al.	
	Docket Number TI-35862 (032350.B534)	Group Art Unit	Filing Date Nov. 6, 2003	

U.S. PATENT DOCUMENTS

		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	A	6,271,143 B1	08/07/01	Mendicino	438	700	05/06/99
	B						
	C						
	D						
	E						
	F						
	G						
	H						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	I							
	J							
	K							
	L							
	M							

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
	N		
	O		
	P		
	Q		
	R		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

U.S. PATENT AND TRADEMARK OFFICE